

Notice of References Cited	Application/Control No. 10/069,517	Applicant(s)/Patent Under Reexamination JAUSSAUD ET AL.	
	Examiner Maria Guerrero	Art Unit 2822	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,374,564	12-1994	Bruel	438/455
	B	US-6,118,181	09-2000	Merchant et al.	257/757
	C	US-5,877,070	03-0199	Goesele et al.	438/458
	D	US-5,387,555	02-1995	Linn et al.	438/455
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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	N					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Yallup et al. "Buried Wsix SOI structures", October 1995, IEEE, pages 137-138.
	V	Goh et al. "Buried metallic layers in silicon using wafer fusion bonding techniques", June 1994, IEEE, pages 625-628.
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.